AccuFiz®MWIR

3.8 µm Infrared Fizeau Interferometer

Accurate IR Measurement

The AccuFiz[®] MWIR laser interferometer operates at a wavelength of 3.8 μ m for accurate measurement of polished and rough-ground optics and metal surfaces.

With simple controls and a built-in visible alignment laser, the system is ideal for measuring concave, convex and afocal IR components, as well as IR telescopes and lens systems. Its ability to capture high slopes enables measurement of aspherical optics without the need for a holographic element.

The AccuFiz MWIR is loaded with standard features, such as 2X continuous zoom, a touch-screen remote and motorized controls.

Optional, vibration-insensitive Dynamic mode enables measurements under almost any environmental condition, without vibration isolation. This insensitivity to environmental factors makes the AccuFiz ideally suited for use in clean rooms and in environmental test chambers. Transmission flats and spheres are available for measuring afocal and focal components and systems.

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Industry Leading Analysis, Standard

The included 4Sight wavefront analysis software features an intuitive interface and excellent ease of use. The Measurement Screen puts all common measurement controls in one place, while the Measurement Flow lets you visualize the entire measurement data flow. 2D and 3D displays, filtering options, and masking tools make it easy to highlight surface shape and texture. Zernike, Seidel, geometric and diffraction analyses are easy to perform. Comprehensive data sharing capabilities let you read, write, save and print most file types.



FEATURES

- 3.8 µm Wavelength
- 2X Continuous Zoom
- Visible Alignment Beam
- Dual Spot Camera Based Alignment Aid
- High Slope Capture for Aspheric Measurement
- Outstanding Data Analysis and Visualization Software

APPLICATIONS

- Focal and Afocal IR Components
- Aspherical Components
- Optical Systems
- Rough-Ground Optics and Metal Surfaces

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Specifications

Configuration	AccuFiz MWIR	
Description	Turnkey Fizeau interferometer system	
Acquisition Mode	Temporal phase shifting, optional dynamic measurement	12.00
Alignment Mode	Visible alignment beam; dual spot camera based alignment aid	
Wavelength	3.8 microns	→ 4.25 ←
Maximum Output	180 mW at 3.8 microns, <5 mW at 532 nm (alignment laser)	
Maximum Cavity Length	>10 m	
Beam Diameter	75 mm collimated	
Polarization	Linear	S S
Pupil Focus Range	±1 m	
Pupil Magnification	2X continuous zoom	0.00
Camera	480 x 480 pixels	o l
Frame Rate	30 frames/sec display	
Motorized Controls	Zoom, focus, beam attenuation	
Computer System	High performance PC with dual monitors	
Operating System	Windows® 7	
System Software	4Sight [™] Analysis Software	
- ,	Reference generation, subtraction, data averaging, masking	
	2D and 3D surface maps	
	Zernike / Seidel / Slope / Geometric / Fourier Analysis	
	Fiducial aided data set mapping	20.25
	Absolute Sphere, 3-Flat calibration	
	HDF4 / HDF5 data format standard, others supported	23.75
	including opd, map, dat, hdf, int, csv and txt	
	Upgrades free during warranty period	l l l l l l l l l l l l l l l l l l l
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Physical Envelope	< 71.9 x 33.0 x 25.4 cm (28.3 x 13.0 x 10.0 in)	
Weight	< 31.8 kg (70 lbs)	
Power consumption	< 750 Watts @100-240VAC, 50/60Hz	
Temperature Range	Operational: 16–27° C (60–80° F), non-condensing	- {
	Storage: -1–38° C (30–100° F), non-condensing	
Warranty	One Year, limited, on-site system installation and operator training	
Options		
Transmission Spheres	Range of focal lengths	
Beam Expanders	Range of expanders on request	
System Performance		
Acquisition Rate	< 30 frames/sec display	
	< 30 frames/sec max data acquisition with optional dynamic mode	
Sample Reflectivity	10 to 100%	
RMS Repeatability	< λ/2000*	
RMS Precision	< \ <i>\</i> 1000**	
One sigms for BMC of 10 date	a sets of calibration mirror, each data set being an average of 16 measurements.	^
-	e of 10 data sets between measured surface and the calibrated surface. Each data	
an average of 16 measureme		
0	rk, and 4Sight is a trademark of 4D Technology Corporation.	
lindows is a registered tradem	ark of Microsoft Corporation.	
Il specifications subject to cha	nge without notice.	VISIBLE AND/OR INVISIBLE
ertain export restrictions apply	Ι.	LASER RADIATION. AVOID EXPOSITE TO BEAM.
		CLASS 38 LASER PRODUCT <180mW at 3.8µm <5mW at 52pm
		 smw at 532nm

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